



UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ellison et al.

Application No.: 10/526,059

Filed: October 13, 2005

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Attorney Docket: 35947-213490

Art Unit: 1722

Examiner: F. Hiteshew

Title: LIGHTLY DOPED SILICON CARBIDE WAFER AND USE THEREOF IN HIGH
POWER DEVICES

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the restriction requirement issued July 25, 2007, Applicants choose the claims identified in the restriction requirement as group I, claims 1-6, drawn to a crystal.

If an interview would advance the prosecution of this application, Applicant respectfully urges the Examiner to contact the undersigned at the telephone number listed below.

The undersigned authorizes the Commissioner to charge fee insufficiency and credit overpayment associated with this communication to Deposit Account No. 22-0261.

Respectfully submitted,

Eric J. Franklin, Reg. No. 37,134
Attorney for Applicants
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Date:

9/25/07